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Initial adsorption structure of ethylene on Si(001) surface at room temperature

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Ethylene (C_2H_4) on the Si(001) surface has been a subject of numerous investigations over a decade. Despite a wealth of experimental and theoretical studies, the adsorption structures are not clearly understood yet. In order to elucidate this controversial issues clearly, C_2H_4 molecules have been non-dissociatively chemisorbed on Si(001)-(2×1) surface at room temperature with an exposure of 100L, and C_2H_4 on Si(001) surface structure has been investigated by coaxial impact collision ion scattering spectroscopy (CAICISS). To determine the adsorption structure of the C_2H_4 molecules definitely, the computer simulation with the two-dimension trajectory count method has been performed for the recently proposed most possible four single molecular adsorption configurations (di- σ on-top, di- σ end-bridge, tetra- σ p-bridge, and tetra- σ r-bridge). The CAICISS spectra and simulation results show that the di- σ on-top structure is better fit than the di- σ end-bridge and two tetra-structures. It is found that the bond length of Si dimer separation on the Si(001) surface with the adsorption of C_2H_4 is 2.35 Å, this implies that the bonding of Si dimers stays intact. It is also found that the bonding length of C-Si and C-C is 1.81 ± 0.01 Å and 1.61 ± 0.01 Å, respectively.